

**RESPONSE AFTER FINAL  
EXPEDITED PROCEDURE**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Art Unit: 1795

Application No.: 10/658,460

Examiner: Rodney Glenn McDONALD

Filed: September 10, 2003

Attorney Docket No.: 029567-00004

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS  
SPUTTERING FILM FORMING APPARATUS

DO NOT ENTER: /RM/

**AMENDMENT UNDER 37 C.F.R. § 1.116**

04/23/2008

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 16, 2008

Sir:

In reply to the February 4, 2008, Office Action, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, begin on page 2;  
and

Remarks begin on page 4.